

2018 Editorial Calendar

(Editorial close date: 6/15)	July • August	* indicates show distribution
High reliability materials		• ICEPT 2018 Shanghai, China (Aug 8-11)
Metal-based wafer-level and 3D printed packaging	9	• SEMICON Taiwan * Taipei, Taiwan (Sept 5-7)
Temporary bonding for high temperature processing of thin glass Chip-package-board co-design		• European MEMS & Sensors Summit Grenoble, France (Sept 19-21)
		 European Imaging & Sensors Summit Grenoble, France (Sept 19-21)
Coaxial socket technology		 Strategic Materials Conference - SMC San Jose, CA (Sept 24-26)
Testing RF devices		
Large-area fan-out processing		

International Directory of Wafer Probers & Probe Cards

Ad Space Close Jun 30 - Ad Materials Close Jul 7

(Editorial close date: (7/20)	September • October	* indicates show distribution		
Effective, Scalable EMI Protection		•SMTA International * Rosemont, IL (October 16-17) • IWLPC-International Wafer-Level Packaging Conference & Exhibition * San Jose, CA (Oct 23-25) • TestConX China 2018 Suzhou, China (Oct 23) Shenzhen, China (Oct 25)		
Embedded RDL				
High density flip-chip and advanced CSP				
High-resolution 3D X-ray metrology				
Advanced substrates and embedded packaging		 MEMS & Sensors Executive Congress) San Jose, CA (Oct 28-30) International Test Conference (ITC) 		
High density advanced packaging (HDAP) design		Phoenix, AZ (Oct 31- Nov 2) • SEMI International Technology		
Direct-placement process for LED's		Partners Conference (ITPC) Maui, Hawaii (Nov 4-7)		
Inspection strategies		 SEMICON Europa Munich, Germany (Nov 13-16) 		
High density advanced packaging design				

International Directory of Defect Inspection Systems

Ad Space Close Sep 8 - Ad Materials Close Sep 15

(Editorial close date: 9/21)	November • December	* indicates show distribution		
5G developments		• EPTC 2018 * Singapore (Dec 4-7) • SEMICON Japan Tokyo, Japan (Dec 12-14) • SEMI European 3D Summit * Dresden, Germany (Jan 22-24, 2019) • SEMICON Korea Coex, Seoul, Korea (Jan 23-25, 2019)		
Cooling solutions for hi-density chips				
Burn-in system technology advancements				
Advanced eWLB for mmWave applications				
Package assembly design Kits				
Collective bonding for heterogeneous integration				
Lithography				
Photonics for next generation applications				
Robust interconnects for MEMS sensors				
Wafer bumping				

Ad Space Close Nov 3 - Materials Close Nov 10